

Attorney Docket No. PHN 17-651

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Johannes J. VAN VAALS

Serial No. : 09/857,310

Filed : June 1, 2001

For : MAGNETIC RESONANCE
IMAGING METHOD AND
SYSTEM (AS AMENDED)

Art Unit : 2862
Examiner : T.A. FETZNER

LETTER TO THE OFFICIAL DRAFTSPERSON

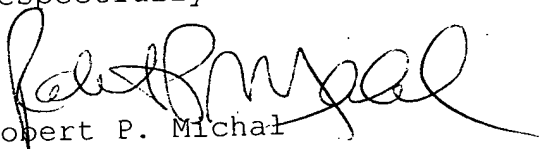
COMMISSIONER FOR PATENTS
Washington, D.C. 20231

S I R :

Attached hereto is Fig. 1 which has been marked in red to show the amendments being proposed thereto. Specifically, Fig. 1 is amended to obviate the Examiner's objection to the drawings set forth in the July 31, 2002 Office Action.

Upon approval of the drawing amendments a new formal drawing for Fig. 1 will be provided.

Respectfully submitted,


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Enclosure: Fig. 1

CERTIFICATE OF MAIL

I hereby certify correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on the date noted below.

Attorney: 
ROBERT P. MICHAL

Dated: October 31, 2002

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not tendered by check attached hereto, authorization to charge the extension fee, or any other fee required in connection with this Paper, to Account No. 06-1378.

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